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Inventor Name Search Result

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Serial#	Patent#	Status	Date Filed	Title	Inventor Name
07548073	Not Issued	161	07/05/1990	METHOD OF FORMING AN INTERCONNECT ON A SILICON INTEGRATED CIRCUIT	DOAN , TRUNG
07618490	5136362	150	11/27/1990	ELECTRICAL CONTACT WITH DIFFUSION BARRIER	DOAN , TRUNG
08348646	Not Issued	161	11/30/1994	METHOD OF DEPOSITING TUNGSTEN NITRIDE USING A SOURCE GAS COMPRISING	DOAN , TRUNG
08527924	5866453	150	09/14/1995	ETCH PROCESS FOR ALIGNING A CAPACITOR STRUCTURE AND AN ADJACENT	DOAN , TRUNG
08626651	5651855	150	04/01/1996	METHOD OF MAKING SELF ALIGNED CONTACTS TO SILICON SUBSTRATES DURING	DOAN , TRUNG
08667907	5691235	150	06/12/1996	METHOD OF DEPOSITING TUNGSTEN NITRIDE USING A SOURCE GAS COMPRISING	DOAN , TRUNG
08741612	6066548	150	10/31/1996	ADVANCE METALLIZATION PROCESS	DOAN , TRUNG
08803950	Not Issued	161	02/21/1997	METHOD FOR CREATING DRAM CONTAINER CAPACITOR	DOAN , TRUNG
08915986	5976976	150	08/21/1997	METHOD OF FORMING TITANIUM SILICIDE AND TITANIUM BY CHEMICAL VAPOR	DOAN , TRUNG

09236761	Not Issued	93	01/25/1999	ETCH PROCESS FOR ALIGNING A CAPACITOR STRUCTURE AND AN ADJACENT	DOAN , TRUNG
09283116	6235571	150	03/31/1999	UNIFORM DIELECTRIC LAYER AND METHOD TO FORM SAME	DOAN , TRUNG
09388450	Not Issued	93	09/02/1999	METHOD FOR IMPROVING CMP PROCESSING	DOAN , TRUNG
09537238	Not Issued	71	03/28/2000	METHOD OF DEPOSITING TUNGSTEN NITRIDE USING A SOURCE GAS COMPRISING SI	DOAN , TRUNG
09571074	Not Issued	93	05/15/2000	ADVANCE METALLIZATION PROCESS	DOAN , TRUNG
09653553	Not Issued	20	08/31/2000	ATOMIC LAYER DOPING APPARATUS AND METHOD	DOAN , TRUNG T.
08868057	6174821	150	06/03/1997	SEMICONDUCTOR PROCESSING METHOD OF DEPOSITING POLYSILICON	DOAN , TRUNG T
09133989	Not Issued	41	08/14/1998	CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING	DOAN , TRUNG T
09586144	Not Issued	93	06/02/2000	CONTROLLABLE OVONIC PHASE-CHANGE SEMICONDUCTOR MEMORY DEVICE AND METHO	DOAN , TRUNG T
07339029	4936950	150	04/14/1989	METHOD OF FORMING A CONFIGURATION OF INTERCONNECTIONS ON A	DOAN , TRUNG T.
07339289	Not Issued	166	04/14/1989	METHOD OF ESTABLISHING ELECTRICAL CONTACTS OF SMALL DIMENSIONS ON A	DOAN , TRUNG T.
07368751	5001079	150	06/20/1989	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE BY FORMING INSULATING	DOAN , TRUNG T.
07441611	Not Issued	168	11/27/1989	METHOD OF FORMING A CONDUCTIVE VIA PLUG OR AN INTERCONNECT LINE OF	DOAN , TRUNG T.
07445969	4999160	150	12/04/1989	ALUMINUM ALLOY CONTAINING COPPER, SILICON AND TITANIUM FOR VLSI	DOAN , TRUNG T.
07485029	5021353	150	02/26/1990	SPLIT-POLYSILICON CMOS PROCESS INCORPORATING SELF-ALIGNED	DOAN , TRUNG T.

07503485	Not Issued	161	04/02/1990	POLYSILICON-SILICIDE- POLYSILICON SANDWICH FOR VLSI DEVICE GATES AND	DOAN , TRUNG T.
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